

PATENT

Docket No. 150.01180101

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Brian A. Vaartstra	)	Group Art Unit:	2814
Serial No.:	10/032,049	)	Examiner:	T. Le
Confirmation No.:	5131	)		
Filed:	December 21, 2001	)		
For:	METHODS FOR PLANARIZATION OF METAL-CONTAINING SURFACES USING HALOGENS AND HALIDE SALTS			

COMMUNICATION

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

Pursuant to a telephone conference with Examiner Thao Le on March 12, 2003, it has come to the Applicant's attention that the submission of February 11, 2003, which included a Response Under 37 C.F.R. §1.116, Exhibit A, and Exhibit B, in connection with the above-identified patent application have been misplaced. Please note that these documents were submitted via facsimile. Enclosed are courtesy copies of the Response Under 3 C.F.R. §1.116, Exhibit A, and Exhibit B as filed with the U.S. Patent & Trademark Office, as well as, the Facsimile Transmission to the PTO, TX Report, and Auto-Reply Facsimile Transmission indicating that the transmission was sent and received by the U.S. Patent & Trademark Office.

Please direct any inquiries to the undersigned attorney.

Respectfully submitted for

MICRON TECHNOLOGY, INC.

By

Mueeting, Raasch & Gebhardt, P.A.

P.O. Box 581415

Minneapolis, MN 55458-1415

Phone: (612)305-1220

Facsimile: (612)305-1228

Customer Number 26813



26813

PATENT TRADEMARK OFFICE

By:

Ann M. Mueeting

Reg. No. 33,977

Direct Dial (612)305-1217

Date

*March 12, 2003*